Quantum magnetometry with spins, mechanics and photons

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High-Sensitivity Magnetometers







Atomic vapor



Diamond



Opto-Mechanics



Physics of NV center





conduction band



Optical pumping and read-out





Optical detected magnetic resonance





MW Frequency (GHz)

Diamond materials





Structure: NV ensemble; single NV; NV nanodiamond

Growing diamond:

a) High-pressure high-temperature (N: ~100ppm)b) Chemical vapor deposition (N: 1ppb-1ppm)

Forming NVs: Bombardment and annealing Delta doping

Measurement Strategies



Sensitivity





Cavity Enhanced Magnetometer



Efficiently address low density ensemble





Microwave antenna -> uniform field distribution Bayat et al., Nano Lett. 14, 1208 (2014)

Hyperfine lines

Separated ¹⁴N hyperfine spectrum ($A_{hf} = 2.2MHz$)



S. Ahmadi et al., Phys. Rev. Applied 8, 034001 (2017)

Implantation vs. Native Defects

• Increase [NV] through radiation damage





- [NV] \approx ppm
- Γ ~ 5-10 MHz
- C < 0.1%
- K. Jensen et al., PRB 87, 014115 (2013)
- CVD crystals native defect density $\rho\approx 1~ppb$



- [NV] $\approx 1 \text{ ppb}$
- Γ ~ 1-2 MHz
- C ~ 1-3%

Sensitivity



S. Ahmadi et al., Phys. Rev. Applied 8, 034001 (2017)

Limitations

- Technical noise
- Finite photon collection

Other works:

PNAS 113, 14133 (2016): 15pT Nat. Phys. 11393 (2015): 290pT NV: 100ppb (and C12 purified)

Improved Sensitivity

larger diode (10x10 mm² vs. 3.6x3.6mm²)



noise cancellation



<u>Shot noise limit:</u> \approx 120 pT Hz^{-1/2}

Cavity optomechanical magnetometry





S. Forstner et al, Phys. Rev. Lett. 108, 120801 (2012)



Thermomechanical noise (Fluctuation-dissipation theorem)

$$S_{th} = 2m\Gamma k_B T$$

Measurement noise from optical measurement

$$S_{mea} \propto rac{V_{probe}}{G^2} + radnoise$$

Quantum-enhanced performance





Setup





Beibei Li, Jan Bilek et al, arxiv:1802.09738









Beibei Li, Jan Bilek et al, arxiv:1802.09738

Summary

bigQ

Diamond magnetometer



S. Ahmadi, H. El-Ella, J. Bindslev, A. Huck, U.L. Andersen, Phys. Rev. Applied 8, 034001 (2017)





Optomechanical magnetometer



B. Li, J. Bilek, U. B. Hoff, L. S. Madsen,S. Forstner, V. Prakash, C. Schafermeier,T. Gehring, W. P. Bowen, U. L. Andersen arxiv:1802.09738